



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Shohei FUJISAWA

Group Art Unit: 1725

Application No.: 10/849,880

Filed: May 21, 2004

Docket No.: 119822

For: LIGHT SOURCE UNIT, METHOD OF MANUFACTURING
LIGHT SOURCE UNIT, AND PROJECTOR

SUPPLEMENTAL PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Specification;

Amendments to the Claims as reflected in the listing of claims; and

Remarks.